

Application/Control No.	Applicant(s)/Patent under Reexamination
10/830,049	OHNISHI ET AL.
Examiner	Art Unit
John R. Nauvon	2810

	SEAR	CHED	
Class	Subclass	Date	Examiner
330	285,129	8/20/2005	NL N
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
			-	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
see text search	8/20/2005	NL		
44				